



YINKE VALVE
FLOW CONTROL

Wafer Dual Plate Check Valves

Wafer Dual Plate Check Valves are configured for compact backflow protection with reduced installation weight. Buyers can compare pressure class, size, materials, end connections and operation, then match the valve to the piping class and service conditions.

Technical Specification

Design Standard	API 594 / ASME B16.34
Size Range	2-48 in
Pressure Classes	Class 150, Class 300, Class 600, Class 900
Body Materials	WCB, CF8M, Duplex 2205, Super Duplex 2507
End Connections	Wafer, Lug, Double Flanged
Operation	Manual, gear or actuated where applicable

Selection Notes

Start with the piping class and service conditions, then review disc motion, hinge or spring behavior, closure response and seat design. For quotation, include orientation, flow direction, allowable pressure drop, closure behavior, body material and end connection.

Materials

Typical project material options include WCB, CF8M, Duplex 2205, Super Duplex 2507. Final material selection should follow corrosion conditions, design temperature, toughness requirements and the approved material specification.

End Connections

Available connection families include Wafer, Lug, Double Flanged. The final facing or weld preparation must match the piping class and approved drawing.

Testing & Documentation

Confirm the required pressure test standard, material certificates, PMI or NDE scope, dimensional inspection, coating records and final document package before production.

RFQ Information

• Valve type and nominal size	• Pressure class / rating
• Body and trim material	• End connection / facing
• Operation or actuator	• Service fluid and design temperature
• Quantity and delivery requirement	• Inspection, testing and document requirements

For quotation, send the valve list, datasheet or project specification together with the required quantity and delivery location.